

CUSTOMER NO.: 2762

FORM PTO-1449

Docket Number (Optional)

2133.062USU

Application Number

Not Yet Assigned

INFORMATION DISCLOSURE CITATION
IN AN APPLICATION

(Use several sheets if necessary)

Applicant

Mund and Leib

Filing Date

Herewith

Group Art Unit

Not Yet Assigned

U. S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
/MW/	5,895,233	4/20/99	Higashi et al.	438	107	

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO
/MW/	0 280 905 A2	9/7/88	Europe			X	
/MW/	DE10222609.1A1	5/23/02	Germany				X
/MW/	DE10222958.9A1	5/23/02	Germany				X
/MW/	DE10222964.3A1	5/23/02	Germany				X
/MW/	DE10252787.3A1	11/13/02	Germany				X
/MW/	DE10301559.0A1	10/30/03	Germany				X

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

/MW/	XP-10232226A-1, Anodic Bonding Technique Under Low-Temperature and Low-Voltage Using Evaporated Glass, Woo-Beom Choi et al., 9 th Int'l Vacuum Microelectronics Conference, St. Petersburg 1996, pgs 427-430

EXAMINER

/Mary Wilczewski/

DATE CONSIDERED

05/03/2007

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP §609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.

